



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, et al. Docket No: TI-25250  
Serial No: 09/199,829 Conf. No: 4119  
Examiner: Julio Maldonado Art Unit: 2823  
Filed: 11/25/98  
For: HYDROGEN PLASMA PHOTORESIST STRIP AND POLYMERIC RESIDUE  
CLEANUP PROCESS FOR OXYGEN-SENSITIVE MATERIALS

AF  
\$2800  
19/ Oral  
hearing  
P. Walker  
2-21-03

REQUEST FOR ORAL HEARING

Assistant Commissioner For Patents  
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

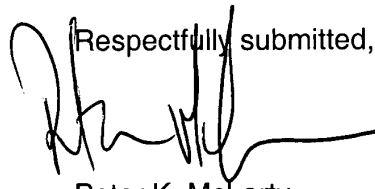
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on 1-24-03.

Ann Trent  
Ann Trent

Dear Sir:

Applicants respectfully request that an Oral Hearing be scheduled on the above identified application. Please charge the \$280.00 fee to the deposit account of Texas Instruments Incorporated, Account 20-0668. **This form is submitted in triplicate.**

02/13/2003 NGBREM1 00000099 200668 09199829  
01 FC:1403 280.00 CH

Respectfully submitted,  
  
Peter K. McLarty  
Attorney for Applicants  
Reg. No. 44,923

Texas Instruments Incorporated  
P.O. Box 655474, MS 3999  
Dallas, TX 75265  
(972) 917-4258

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